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CONFIRMATION NO. 5346

<b>SERIAL NUMBER</b> 10/762,526	<b>FILING OR 371(c) DATE</b> 01/23/2004 <b>RULE</b>	<b>CLASS</b> 216	<b>GROUP ART UNIT</b> 1763	<b>ATTORNEY DOCKET NO.</b> 2557-000177/US	
<b>APPLICANTS</b> Chang Won Choi, Seoul, KOREA, REPUBLIC OF; Jong Baum Kim, Yongin-Si, KOREA, REPUBLIC OF; Tae Ryong Kim, Suwon, KOREA, REPUBLIC OF; Jung-Woo Seo, Suwon, KOREA, REPUBLIC OF; Chang Ju Byun, Youngin-Si, KOREA, REPUBLIC OF;					
<b>** CONTINUING DATA *****</b>					
<b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 2003-33844 05/27/2003					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 04/26/2004</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <u>Allowance</u> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWING</b> 16	<b>TOTAL CLAIMS</b> 44	<b>INDEPENDENT CLAIMS</b> 6
<b>ADDRESS</b> 30593					
<b>TITLE</b> Wafer edge etching apparatus and method					
<b>FILING FEE RECEIVED</b> 1460	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		